

10th International Conference of the European Society for Precision Engineering and Nanotechnology

Session 2B: Nano & Micro Metrology II

Wednesday 2nd June 2010, 16:45-17:50

Chairman: Dr K. Carneiro, DFM, DK

O2B.1 (Keynote)	Mass Manufacturing on Micron Scale Dr O. Hoitinga <i>Philips, NL</i>
O2B.2	Further Improvements of the Measurement Capability of a Metrological Large Range AFM Dr G. Dai <i>Physikalisch-Technische Bundesanstalt (PTB), DE</i>
O2B.3	A Novel Three-axis Vibrating Micro-CMM Probe with Isotropic Probing Forces Mr J. Claverley <i>National Physical Laboratory, UK</i>